

Electronic Patent Application Fee Transmittal

Application Number:	10509338			
Filing Date:	08-Oct-2004			
Title of Invention:	METHOD FOR SUPPRESSING CHARGING OF COMPONENT IN VACUUM PROCESSING CHAMBER OF PLASMA PROCESSING SYSTEM AND PLASMA PROCESSING SYSTEM			
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Attorney Docket Number:	260055US2SPPCT			
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Patent-Appeals-and-Interference:				
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